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January 18, 2000

Box PATENT APPLICATION

Assistant Commissioner for Patents
Washington, D.C. 20231

Re: New U.S. Patent Application
Our Ref: 622/48561

Sir:

Transmitted herewith for filing is the patent application of:
Martin Dubs et al.

entitled: SPUTTER CHAMBER AS WELL AS VACUUM TRANSPORT CHAMBER
AND VACUUM HANDLING APPARATUS WITH SUCH CHAMBERS

Enclosed are:

1. German Specification, including 34 claims (28 pages).
2. 9 Sheets of Formal xx Informal drawings
showing Figs. 1 - 10
3. X Declaration and Power of Attorney (**unexecuted**).

The filing fee is being deferred..

Respectfully submitted,

Donald D. Evenson

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Registration No. 26,160

DDE:rcs